

ABSTRACT



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Disclosed is a method of manufacturing a magnetic recording medium capable of effectively and reliably removing foreign materials on the surface of a magnetic recording medium, preventing a mask layer from remaining on the surface of the magnetic recording medium, and forming the pattern of a magnetic layer with high productivity. The method of manufacturing a magnetic recording medium includes: a step of forming a magnetic layer on a non-magnetic substrate; a step of forming a mask layer on the magnetic layer; a step of patterning the mask layer to form a mask pattern; a step of forming a magnetic recording pattern on the magnetic layer using the mask pattern; a step of burnishing the surface of the mask pattern with an abrasive; and a step of removing the mask pattern.